



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/623,866 Confirmation No. : 6399  
First Named Inventor : Yoshihiro KATO  
Filed : July 22, 2003  
TC/A.U. : 1763  
Examiner : J. Lund  
  
Docket No. : 101246.52582US  
Customer No. : 23911  
  
Title : Plasma Process System and Plasma Process Method

**REPLY**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following proposed amendments and remarks are respectfully submitted in response to the final Office Action dated January 16, 2007, the period for response having been extended to May 16, 2007 by the attached Petition for Extension of Time.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper. **No additional claims fees are due.**

**Remarks** begin on page 10 of this paper.